EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
2	130	From PLUS "15991565" **Hallor9" *1900088" *501247" *5222091 *501247" *5222091 *501247" *5222091 *501247" *5222091 *501247" *5222091 *501257" *5152564" *501257" *5152564" *501257" *615057" *6150576" *50000117469" *50000117469" *50000117469" *5000017469" *5000017469" *50000017469" *50000017469" *50000017469" *50000017469" *5000000000000000000000000000000000000	US-PGPUR USPAT, USOC; FPRS; ENO; PPC; DERWENT; IBM_TOB	OR .	ON	(2010/12/09 09:07
L4	1	(position\$3 adj device) with triaxial with biaxial and diode with laser	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/09 09:15
L5	11372814	(@ad>"20031203" @prad>"20031203" @rlad>"20031203")	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/09 09:15
L6	608	(position\$3 adj device) and (wafer substrate) and diode with laser not 5	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/09 09:16

L7	0	(position\$3 adj device) and (wafer substrate) and diode with laser with circular with contact not 5	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/09 09:16
L8	11	(position\$3 adj device) and (wafer substrate) and diode with laser with contact with surface not 5	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/09 09:17
S1	9735	(wafer substrate) with (contact\$3 connect\$3 bond \$3) with (diode) not @py>"2003"	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/08 14:00
S2	7496	S1 not (@ad>"20031203" @prad>"20031203" @rlad>"20031203")	US-PGPUB; USPAT; DERWENT	OR	ON	2010/12/08 14:04
S3	220	\$1 and (position\$3) and hold \$5 and frame and mov\$5 not (@ad>"20031203" @prad>"20031203" @riad>"20031203")	US-PGPUB; USPAT; DERWENT	OR	ON	2010/12/08 14:05
S4	1272	257/414.ccls.	US-PGPUB; USPAT; DERWENT	OR	ON	2010/12/08 16:37
S5	24	257/414.ccis. and (apparatus device) and (wafer substrate) with (bond\$3 contact\$3 adhes \$5) with diode	US-PGPUB; USPAT; DERWENT	OR	ON	2010/12/08 16:38
S6	15	257/414.ccis. and (apparatus device) and (wafer substrate) with (bond\$3 contact\$3 adhes \$5) with diode not \$2	US-PGPUB; USPAT; DERWENT	OR	ON	2010/12/08 16:38
S7	2	"257".clas. and (apparatus device) and (wafer substrate) with (bond\$3 contact\$3 adhes \$5) with diode with laser and (clamp holder) and frame and pressure not \$2	US-PGPUB; USPAT; DERWENT	OR	ON	2010/12/08 16:41
S8	23	257/777.ccls. and (wafer substrate) with laser with diode	US-PGPUB; USPAT; DERWENT	OR	ON	2010/12/08 16:44
S9	108	(elke with zakel).in.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/08 17:10

S10	1	(elke with zakel).in. and diode adj laser with arrangement	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/08 17:10
S11	1	(elke with zakel).in. and diode adj laser with component	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/08 17:10
S12	1	(ghassem with azdasht).in. and diode adj laser with component	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/08 17:10
513	5	(ghassem with azdasht).in. and diode adj laser and component	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/08 17:11

EAST Search History (Interference)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S14	1	(frame and diode and laser and component and contact and damp).dm.	US-PGPUB; USPAT	OR	ON	2010/12/08 17:07
S15	61	(frame and diode and laser and component and contact).cim.	US-PGPUB; USPAT	OR	ON	2010/12/08 17:08

12/9/2010 9:18:21 AM

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